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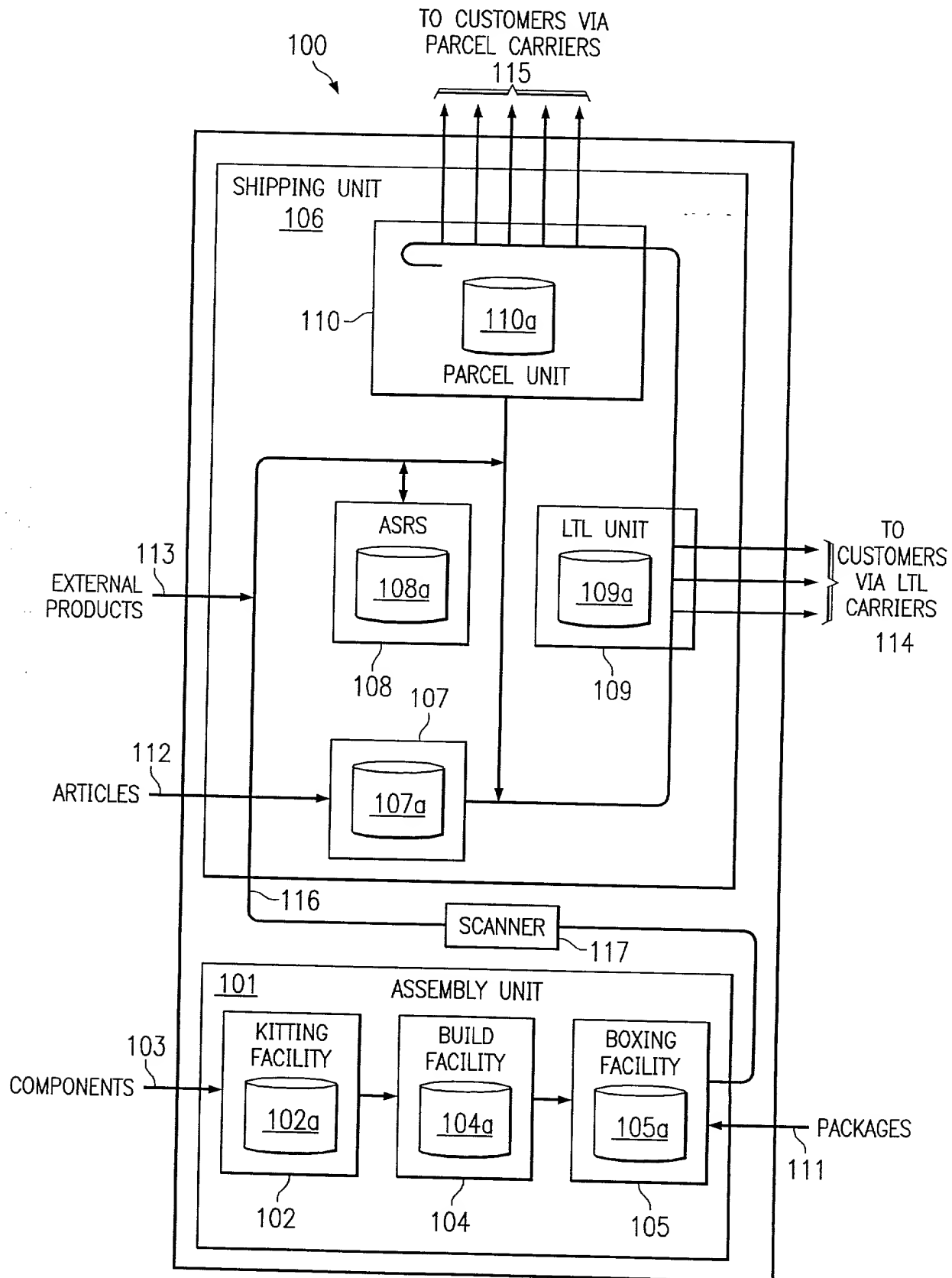


FIG. 1

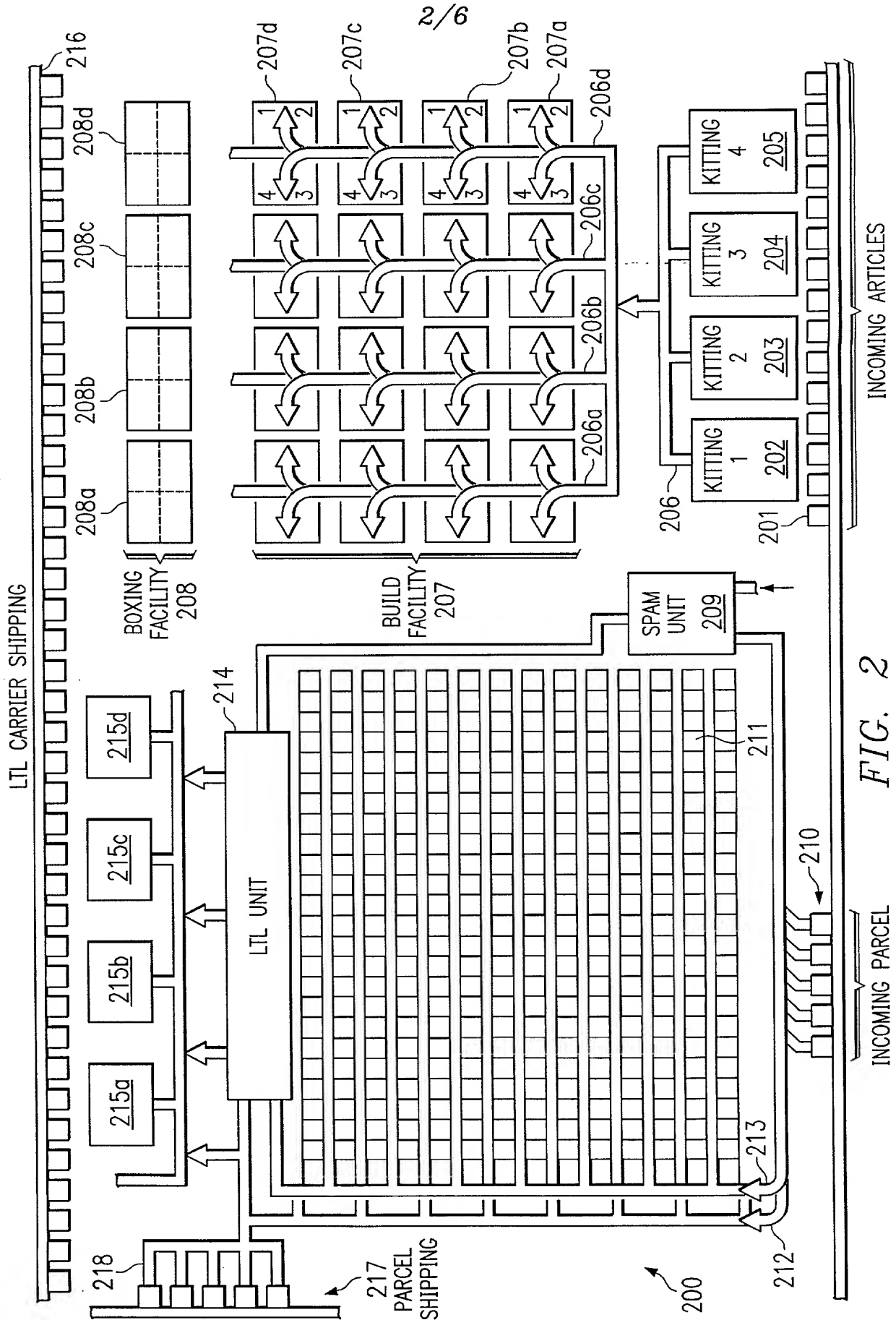
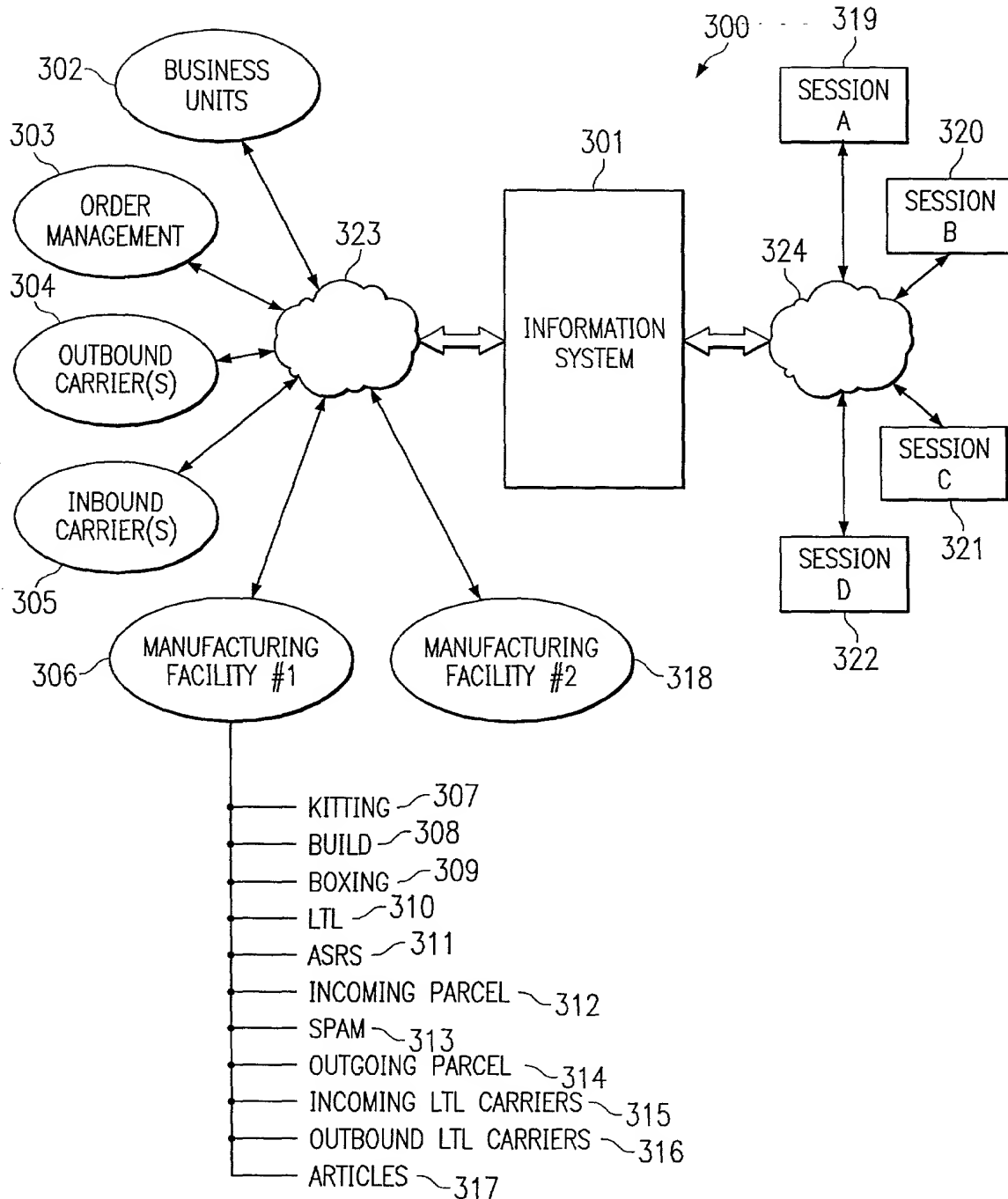


FIG. 2

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FIG. 3



METHOD, SYSTEM AND FACILITY FOR
MONITORING RESOURCES WITHIN A
MANUFACTURING ENVIRONMENT

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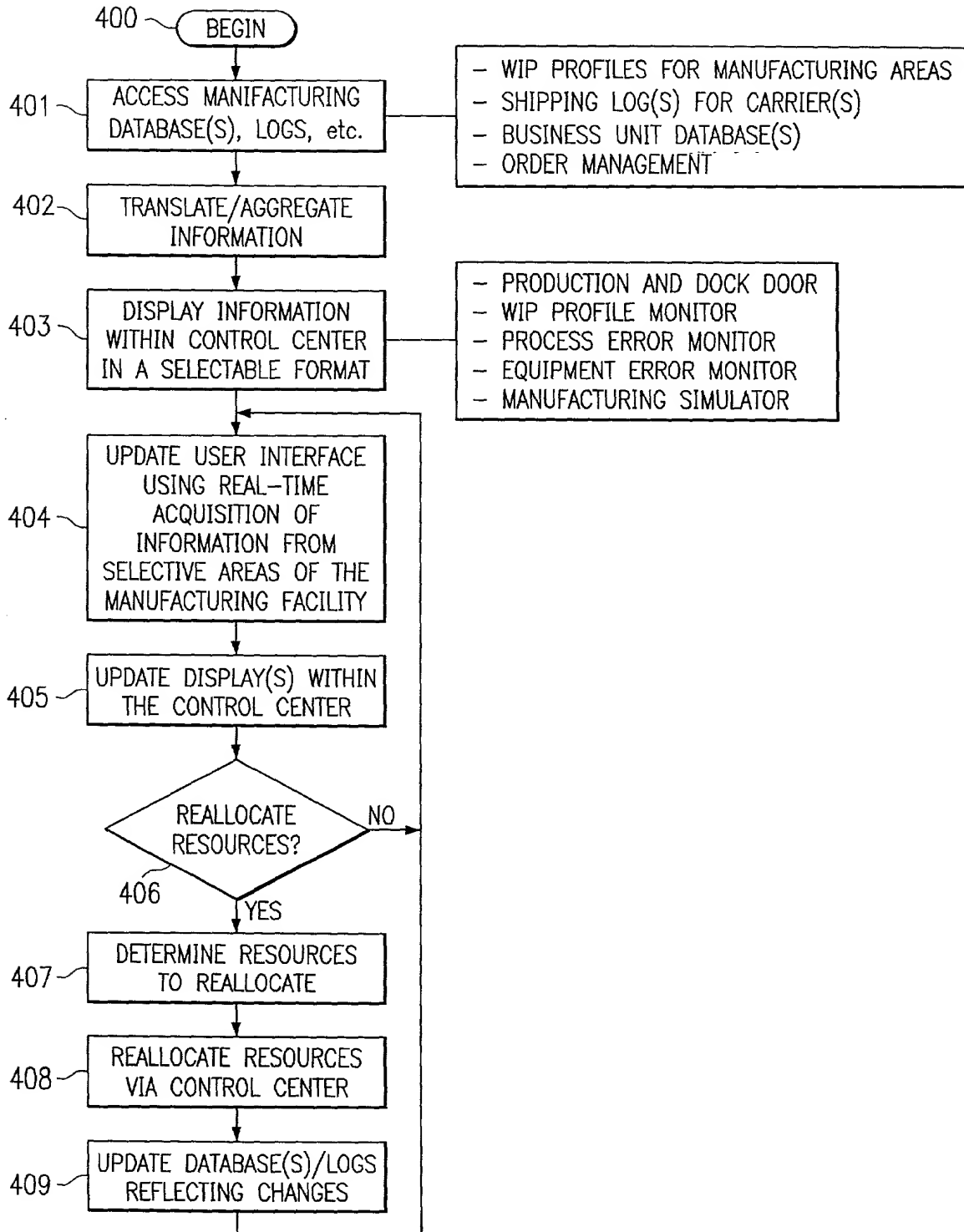


FIG. 4

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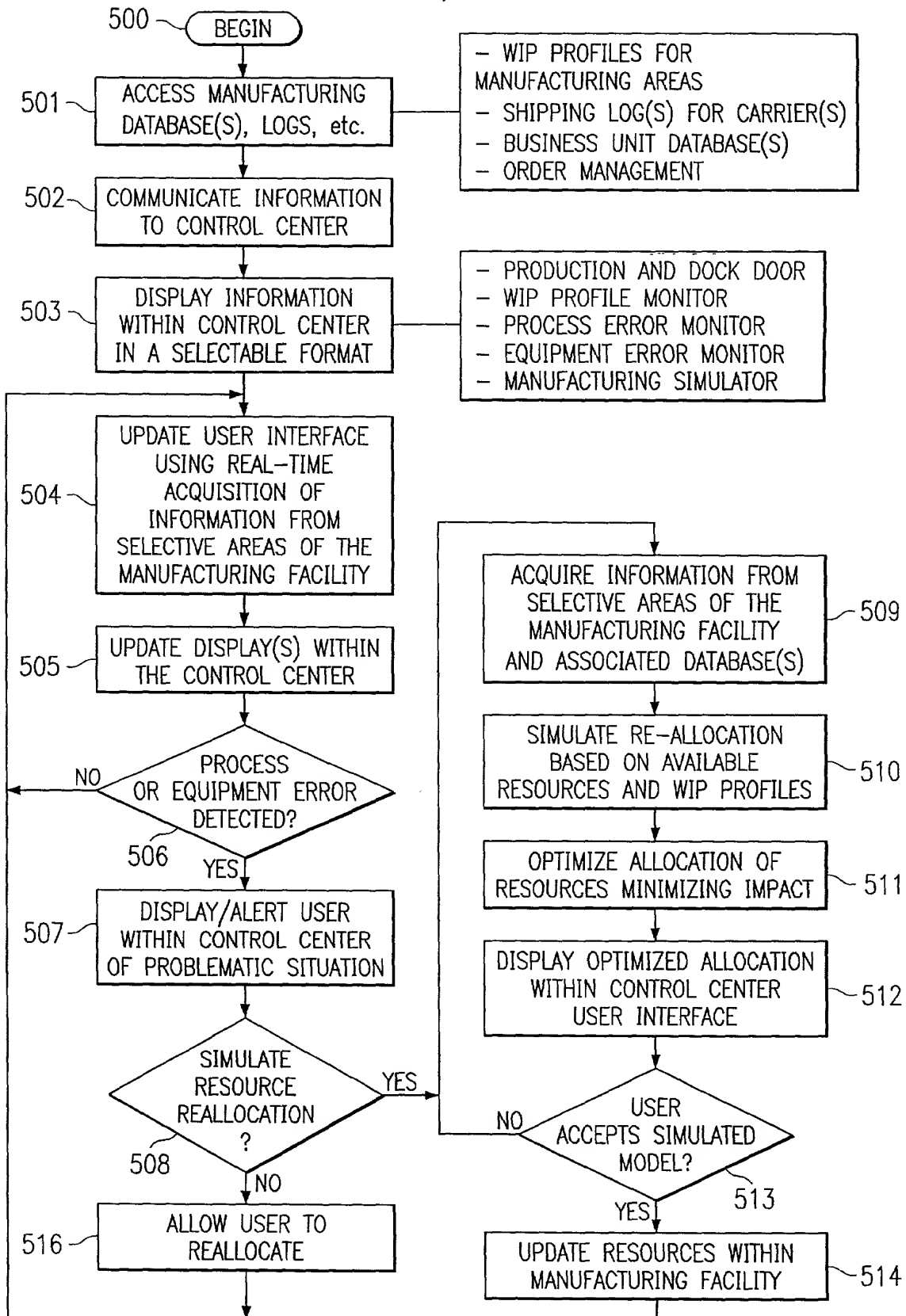


FIG. 5

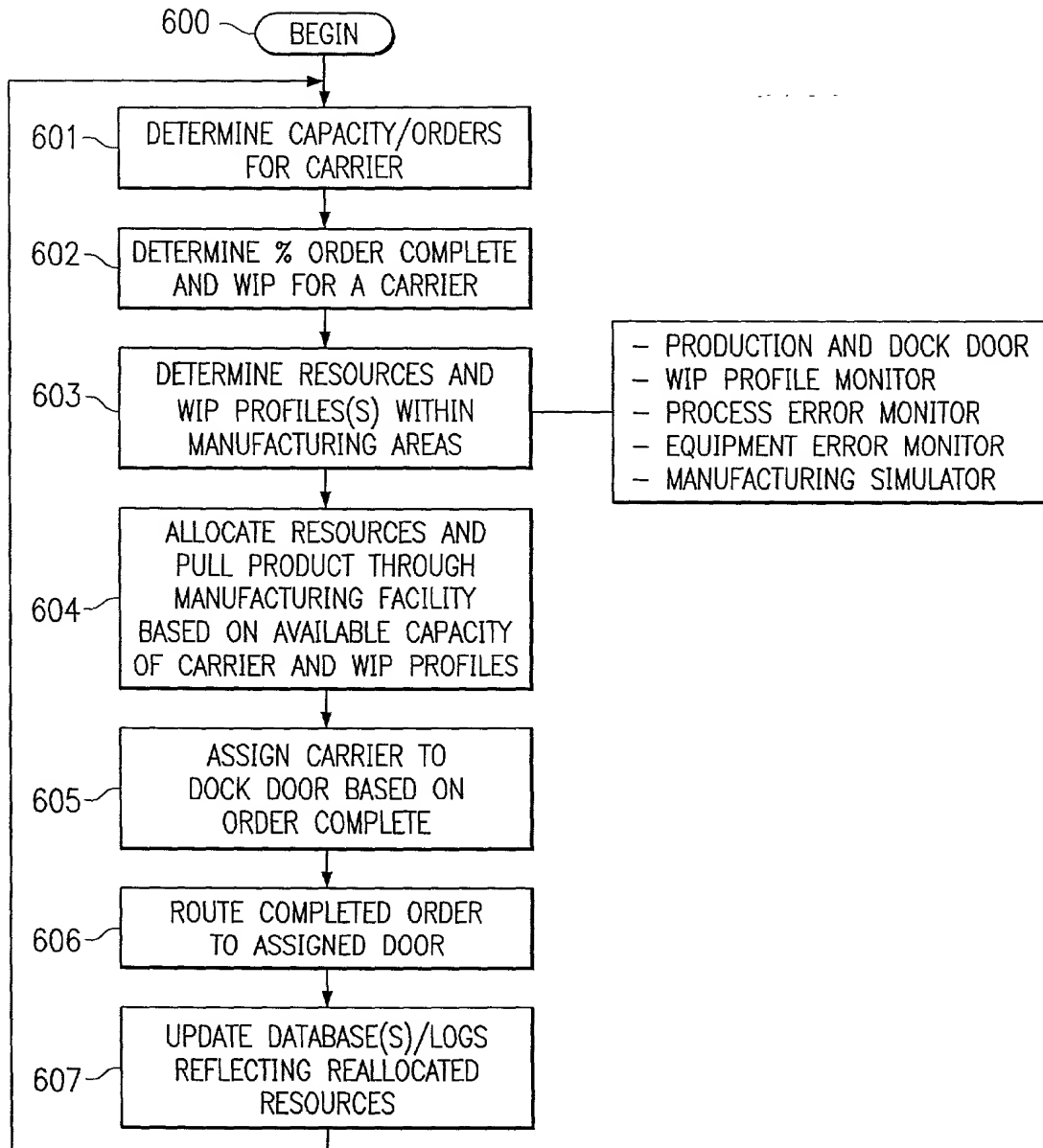


FIG. 6